

**AMENDMENTS TO THE SPECIFICATION:**

Please amend the specification as follows:

**Amend the paragraph [0024] on page 4, to read as follows:**

[0024] The present invention further provides in yet another aspect thereof a method of making quantum size effect micro particles, characterized in that it comprises the steps of: introducing silane into a VHF-band plasma of argon while controlling the time duration in which the silane is so introduced to form Si single crystal micro particles with their particle size controlled; forming on a substrate a layers of such Si single crystal micro particles so formed; and converting respective surface areas of the said Si single crystal ~~macro~~ micro particles in the said layer on the said substrate in the presence of a gaseous atmosphere into insulating films.